

3D silicon pixel detectors for the ATLAS Forward Physics (AFP) experiment

PRELIMINARY Results

Jörn Lange, Iván López Paz, Andrea Micelli, Sebastian Grinstein

IFAE Barcelona

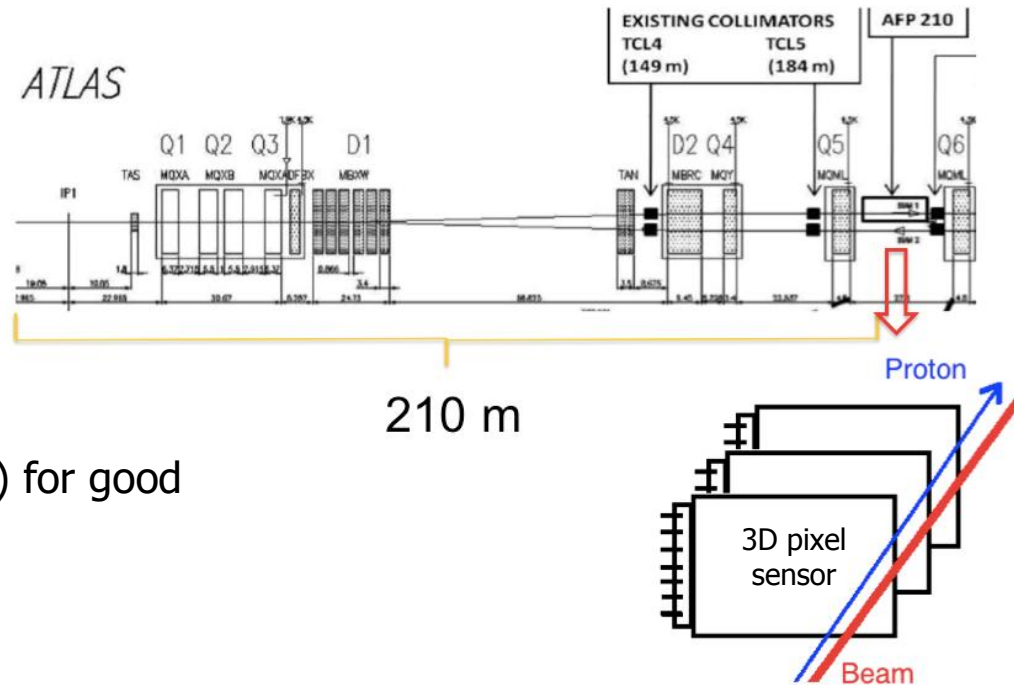
9th Trento Workshop Genova 27.02.2014



Introduction

- Atlas Forward Physics (AFP)

- Diffractive physics: protons leave pp interaction intact
→ **very forward protons**
- Combination of 3D pixel tracker and fast timing detectors (pile-up removal)
- Detectors close to the beam** (2-3 mm) for good acceptance



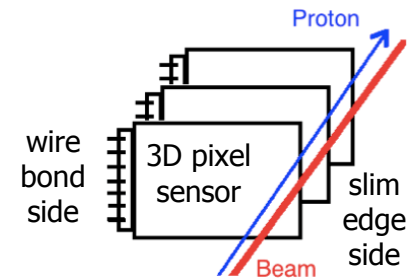
- Status of the proposal

- AFP passed ATLAS Physics review** (24.01.)
- Installation planned for end of 2015
→ second use of 3D silicon sensors in HEP experiment!

Pixel Requirements

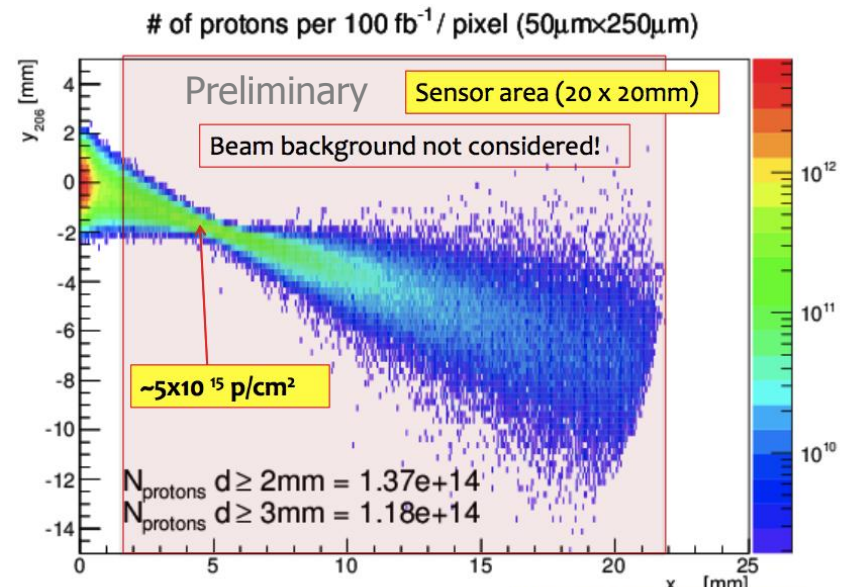
- Pixel detector requirements

- ~10 μm tracking resolution in one direction
- 2x2 cm^2 active area
- Slim edge** of side facing beam: ~100-200 μm
- Highly non-uniform irradiation**
 5×10^{15} p/cm² (7 TeV p!) to several orders of magnitude lower on one sensor (preliminary, depends on final specs)



→ **Baseline:**

3D FE-I4 sensors with slimmed edge

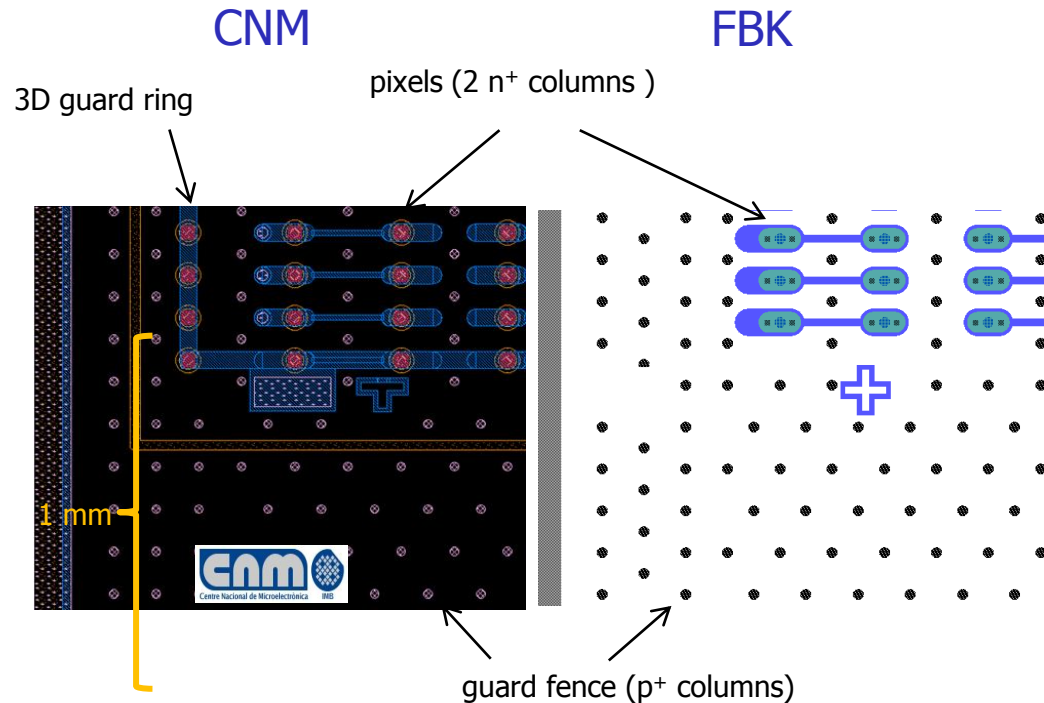


Olda Kepka, Sasa Kupco (FZU, Prague)

Sensors and Edge Slimming

- FE-I4 3D IBL sensors (CNM and FBK)

- 336x80 pixels of $50 \times 250 \mu\text{m}^2$
- p-type bulk, 2 n^+ columns per pixel
- Edge termination:
 - CNM: 3D guard ring of n^+ columns + p^+ ohmic-column fence
 - FBK: p^+ ohmic-column fence
 - Left/right already 200 μm slim edge
 - Bottom: >1 mm bias tab (not needed!)
- IBL spares (not always best quality)



Sensors and Edge Slimming

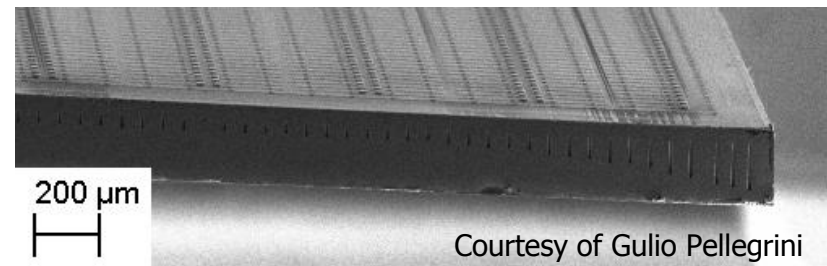
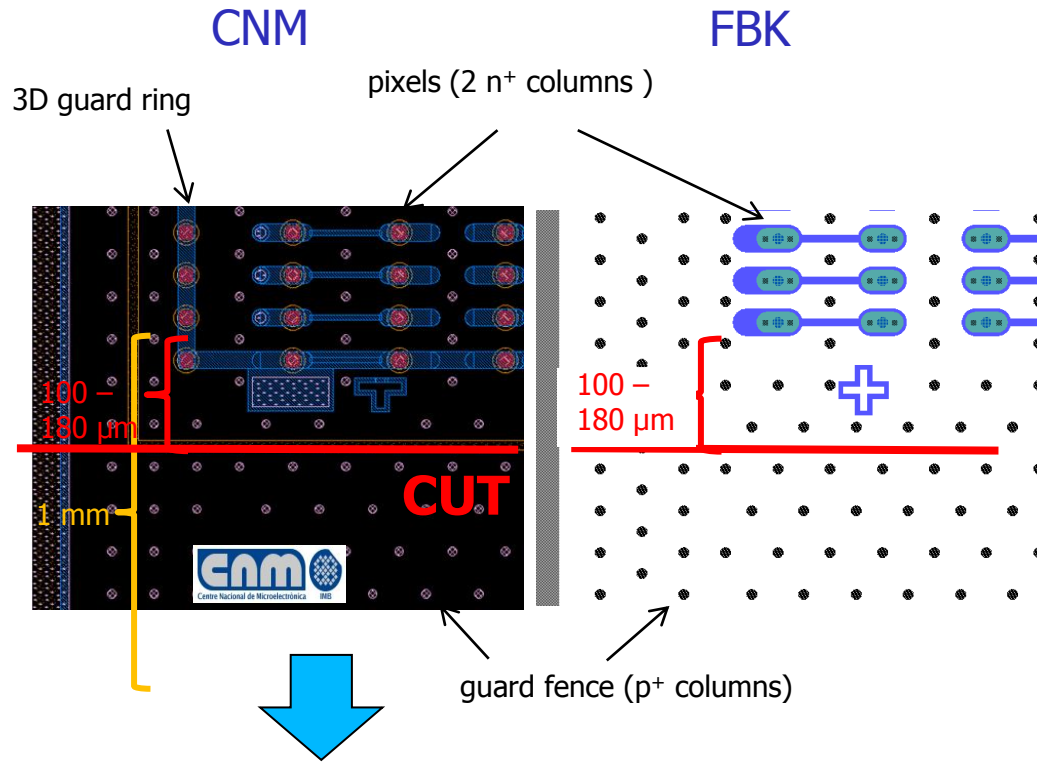
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 - Left/right already $200 \mu\text{m}$ slim edge
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- IBL spares (not always best quality)

- Edge slimming:

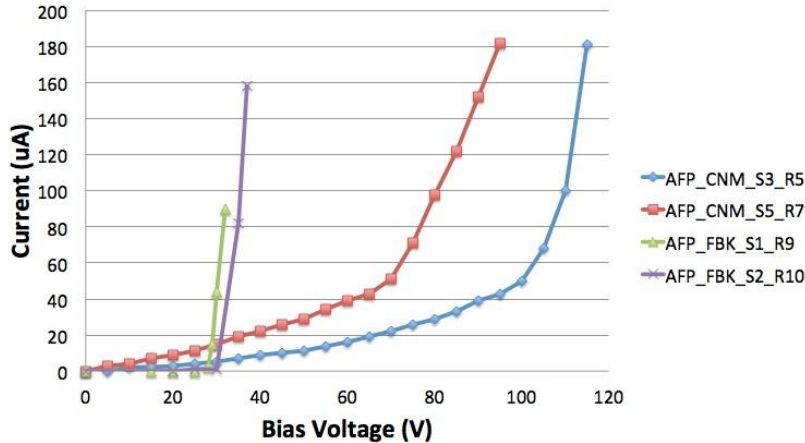
- Cut IBL sensors' inactive bottom edge down to $100\text{--}180 \mu\text{m}$ (FE-I4 chip: $80 \mu\text{m}$ dead region)
- Technique here: standard diamond-saw cut
- Previously also investigated: sensors with SCP slimming with promising results

see A. Micelli, 21st RD50 workshop Nov 2012; S. Grinstein, 8th Trento workshop 2013



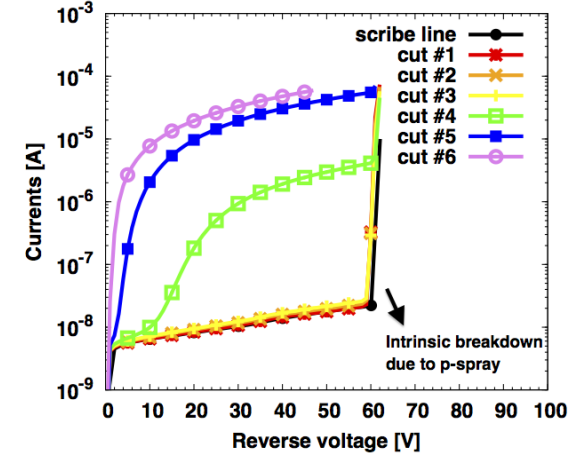
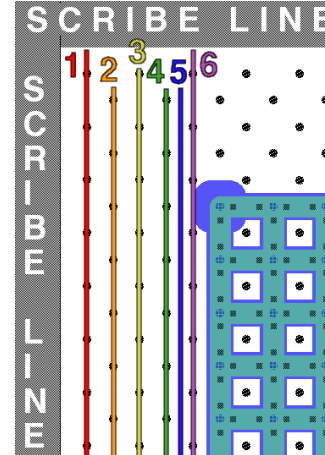
Current and Noise

IV of sensors used here (2 FBK, 2 CNM):
normal for used sensor-quality class

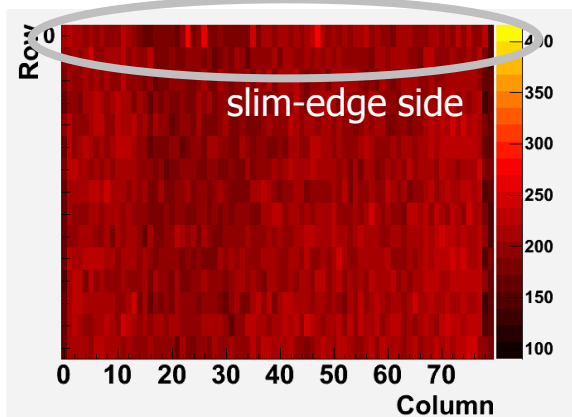


Previous study on FBK sensors:
IV unaffected up to 100 µm cut line

M. Povoli et al., JINST 7 (2012) C01015



Noise of CNM_S3_R5

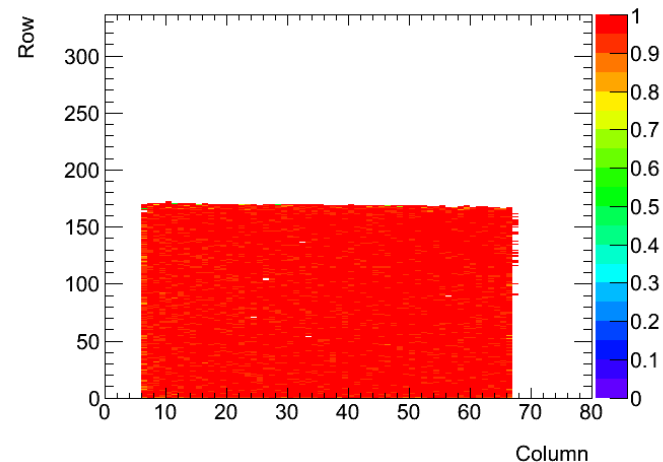


- No anomalous current and noise after edge-slimming to 100-180 µm

Efficiency of Slim-Edge Sensors in Test Beam

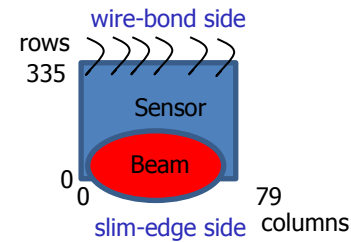
- DESY II Test beam: 4 or 5 GeV electrons
- ACONITE telescope (EUDET type)
- Normal incidence
- 1 reference IBL sensor,
4 slimmed-edge AFP sensors
- Average efficiency after slimming (97-99%)
comparable to IBL reference
→ what about edges?

Thanks to all test beam participants,
esp. I. Rubinskiy (DESY), D. Pohl (Bonn),
O. Korchak (Prague), Sh. Hsu (Washington)

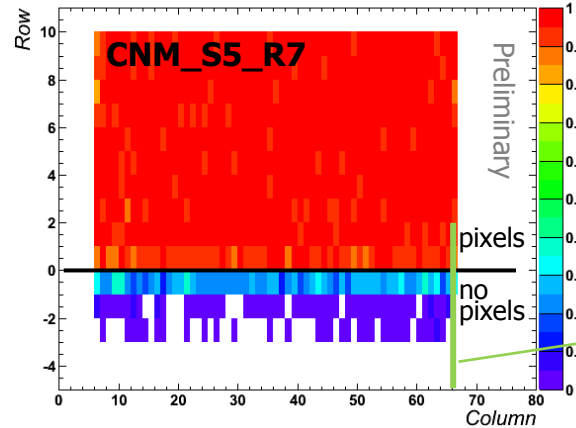


	DUTs				
Sample	CNM-55 (Refer.)	CNM_S3_R5	FBK_S5_R10	CNM_S5_R7	FBK_S1_R9
Edge	Regular	Slimmed	Slimmed	Slimmed	Slimmed
Bias [V]	30	30	20	30	20
Threshold [ke]	2.8	1.9	2.0	2.0	2.0
Efficiency	98-99%	98.3%	98.6%	96.9%	98.0%

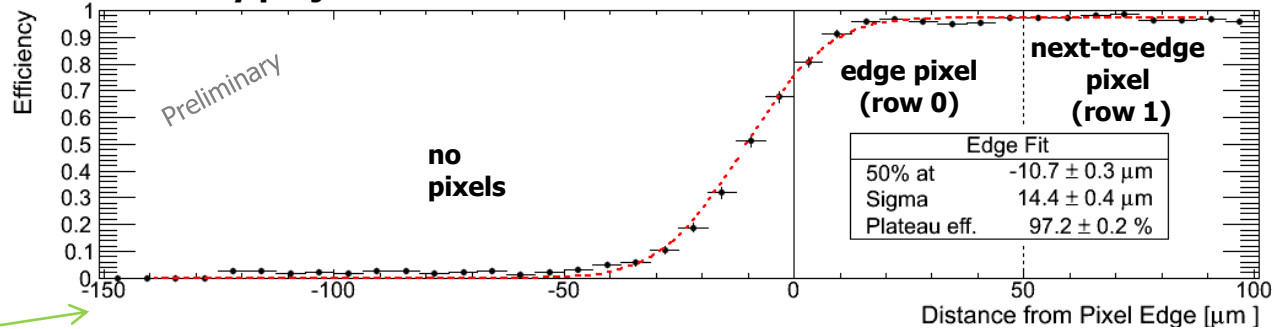
Edge Efficiency (Slim Edge Bottom Side)



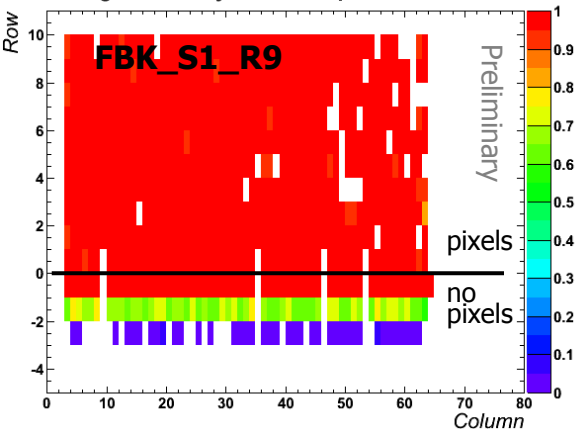
Y Edge Efficiency Sensor Map Bottom



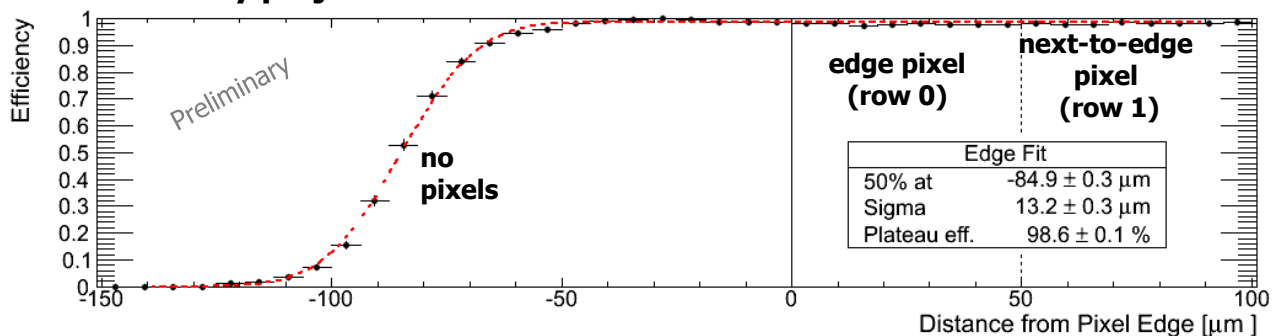
Efficiency projection CNM



Y Edge Efficiency Sensor Map Bottom



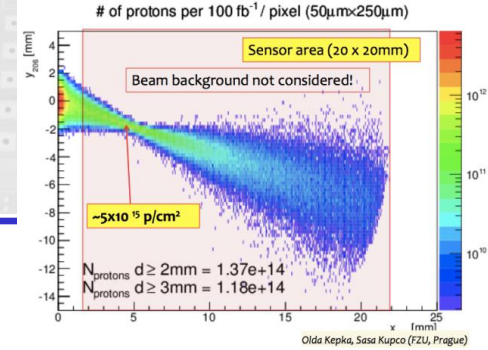
Efficiency projection FBK



- Efficiency stable up to last pixel
 - For FBK even $\sim 80\text{-}85 \mu\text{m}$ beyond (efficient edge due to absence of guard ring)

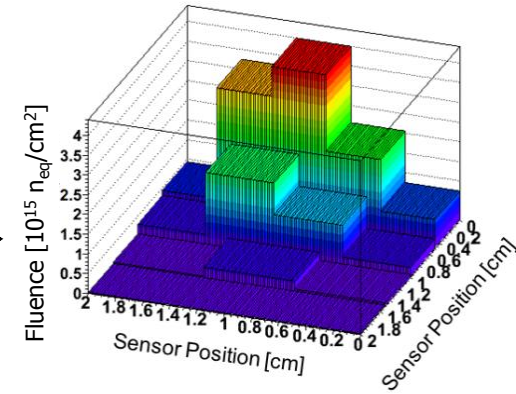
→ same behaviour as for non-slimmed edge!

Non-Uniform Irradiation

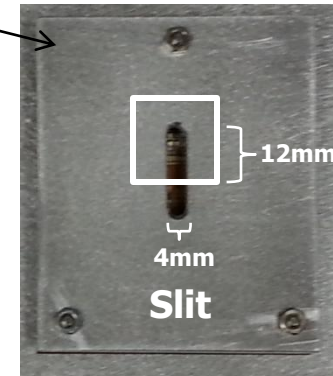
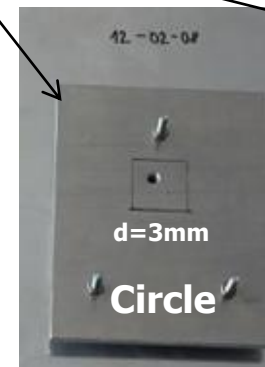


- **Non-uniform irradiation:**
Can detector be operated to give high efficiency both in unirradiated region ($V < V_{BD}$ needed) and in irradiated region ($V > V_{dep,irr}$ needed)?
- **First test beam study** in 2012 with focussed CERN-PS 23 GeV irradiation promising: 98% efficiency
see A. Micelli, 21st RD50 workshop Nov 2012; S. Grinstein, 8th Trento workshop 2013
- But fluence spread was large
- **Another irradiation with more localised fluence:**
23 MeV protons (KIT) through hole in Al plate (5 mm thick)
→ focus of following slides

Fluence map of CERN-PS irradiation:



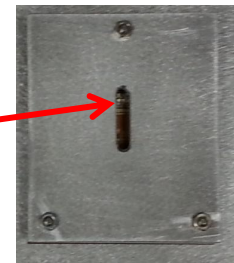
Al shields at Karlsruhe:



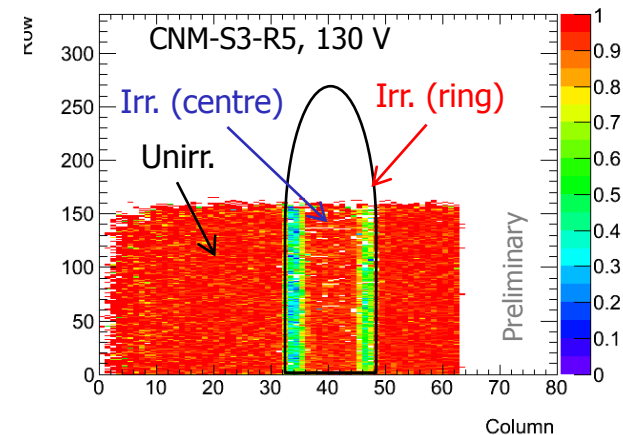
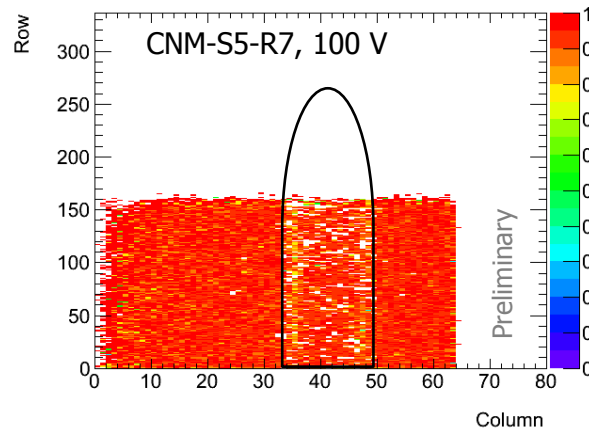
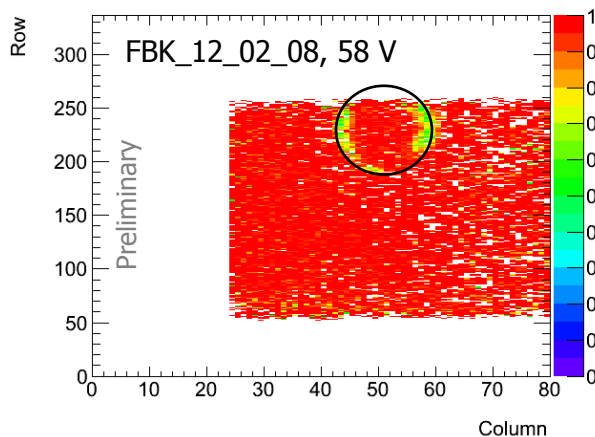
Non-Uniform Irradiation	PS 23 GeV p Focussed beam	KIT 23 MeV p Hole (circle)	KIT 23 MeV p Hole (slit)	
Φ [$10^{15} n_{eq}/cm^2$]	4.0 (max)	1.8	3.3	3.6
Sample	CNM 57	FBK 12_02_08	CNM S5-R7	CNM S3-R5
Edge	Regular	Regular	Slimmed	Slimmed

Efficiency of Irradiated Devices

- Test beam: DESY (KIT irr. devices), CERN (PS irr. device), normal incidence, $T < -20\text{ °C}$
- Different runs at different bias voltages of irradiated sample (V limited by high I_{leak})
- Challenging to tune threshold in such non-uniformly irradiated sensors
- Noisy and dead pixels masked
- Irradiated hole (centre) almost as efficient as unirradiated region
- Ring of lower efficiency at edge of hole
 - Probably due to scattering of p at edge of Al shield -> loose energy -> much more damaging

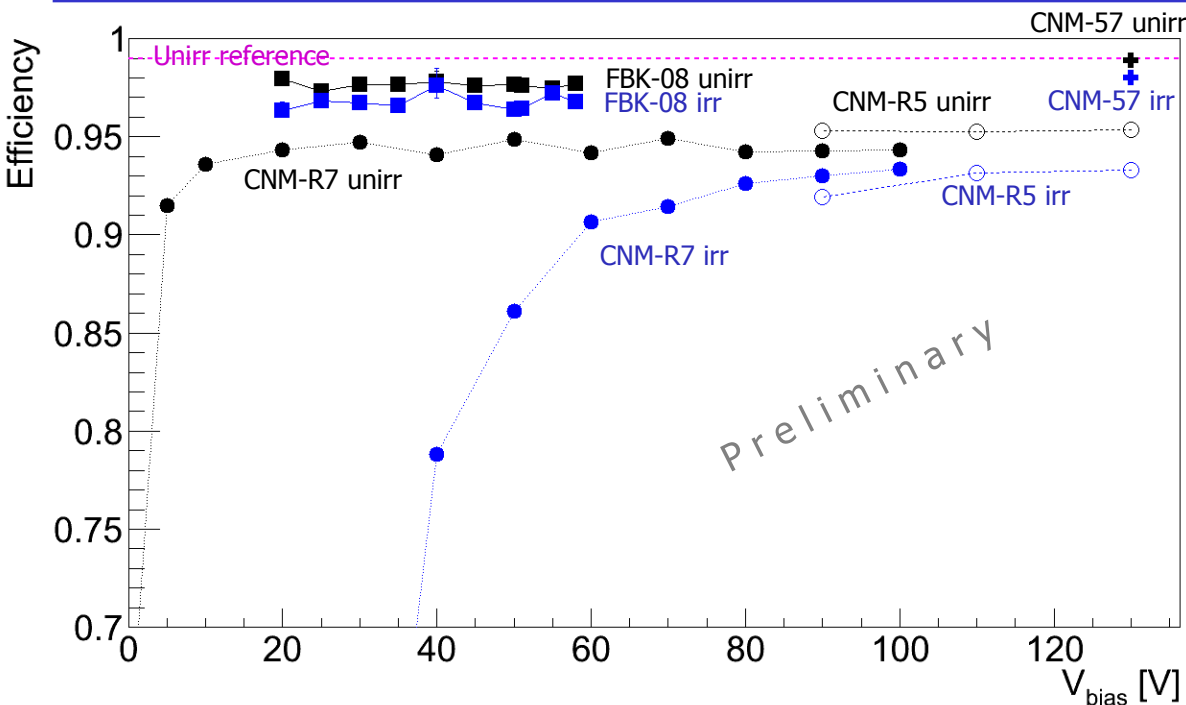


Efficiency Sensor Maps



Efficiency

for unirradiated and irradiated (centre) area

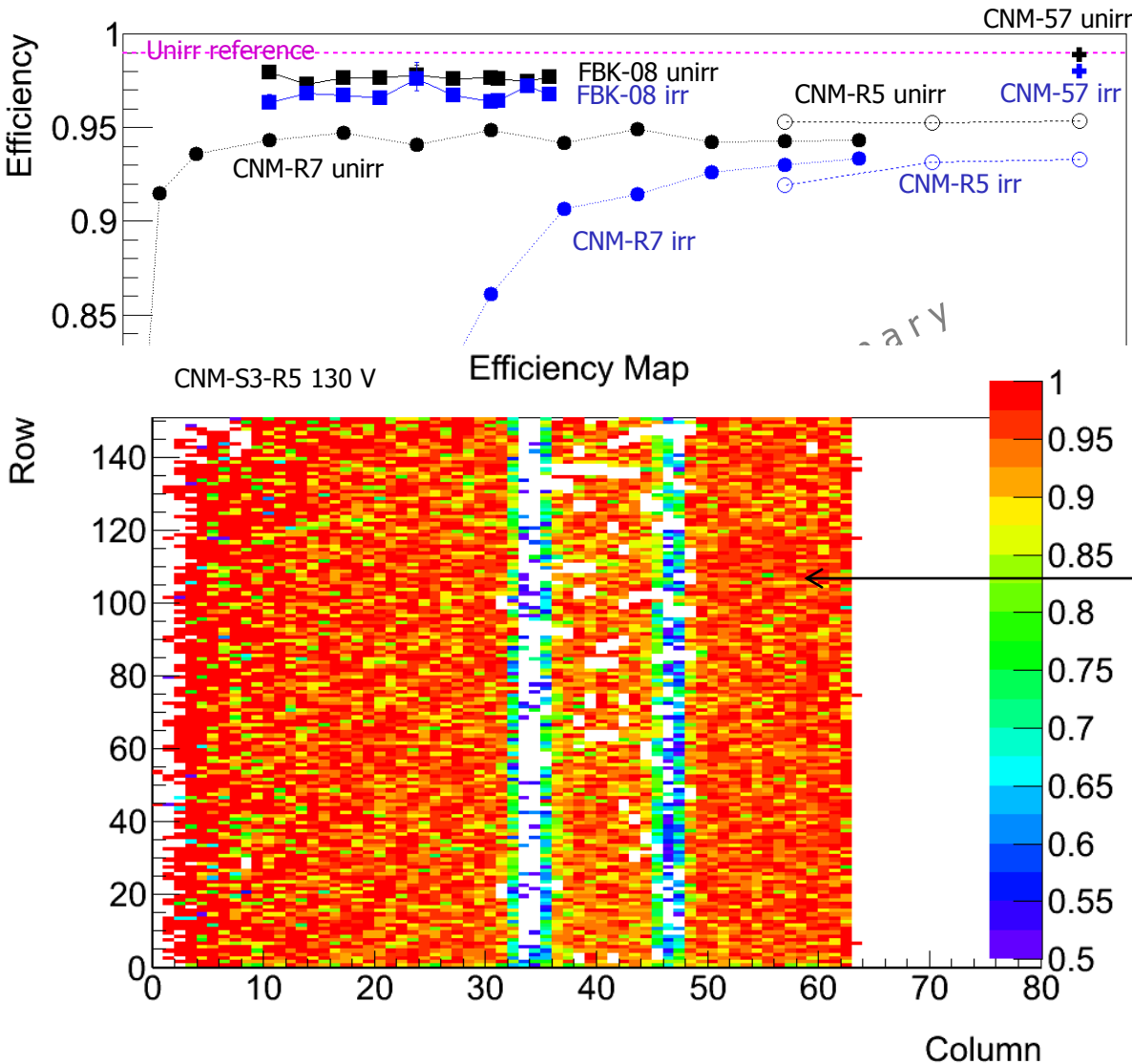


- Irradiated part (centre) almost as efficient as unirrad. part
- Irradiation through hole (KIT): offset for CNM devices
 - Both unirrad. and irr. area
 - Note different fluence, irr. area, threshold, edge
 - Threshold of 2 ke gives 1% more
 - Problem with tuning? Non-uniform eff. even in unirrad. area

Non-Uniform Irradiation	Unirr. Reference	PS Focussed	KIT Hole (circ.)	KIT Hole (slit)	
Φ [10^{15} n _{eq} /cm ²]	Unirr.	4.0 (max)	1.8	3.3	3.6
Sample	CNM 55	CNM 57	FBK 12_02_08	CNM S5-R7	CNM S3-R5
Edge	Regular	Regular	Regular	Slimmed	Slimmed
Threshold [ke]	3	1.7	2	3	3

Efficiency

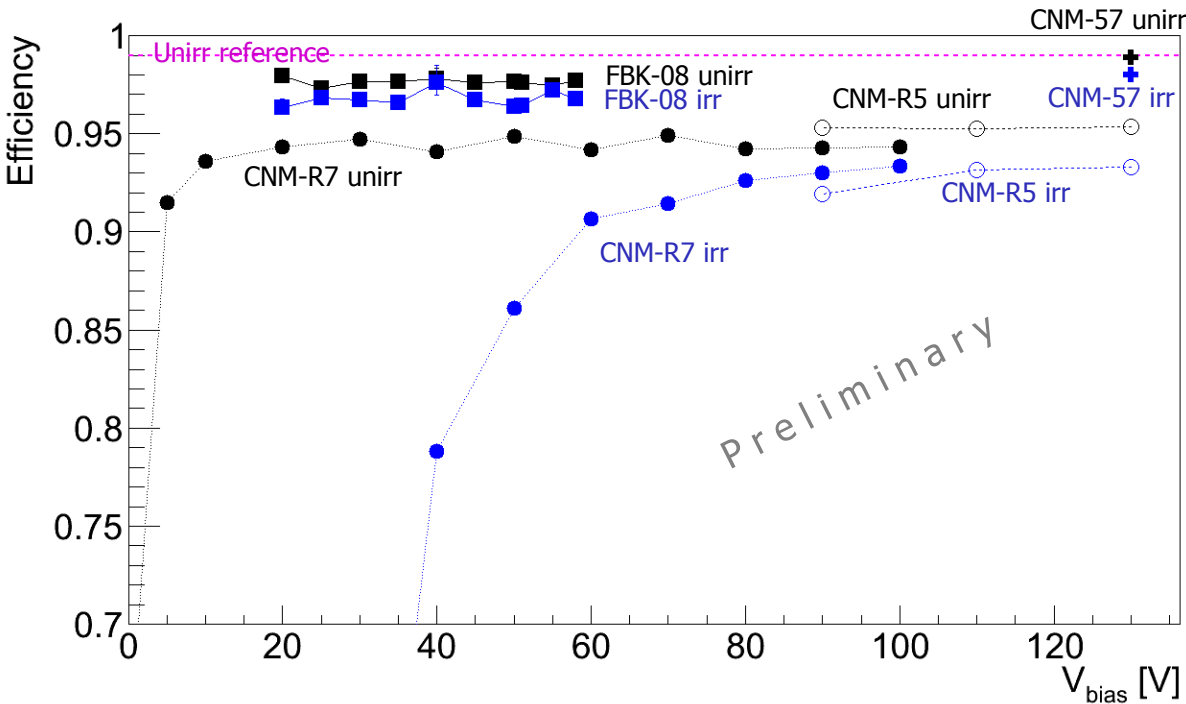
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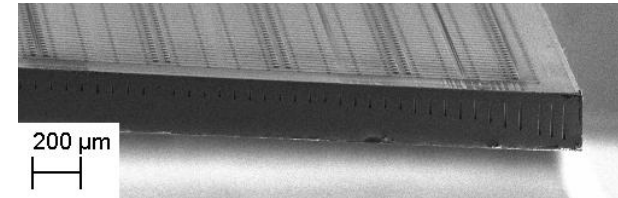


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 - Both unirrad. and irr. area
 - Note different fluence, irr. area, threshold, edge
 - Threshold of 2 ke gives 1% more
 - Problem with tuning? Non-uniform eff. even in unirrad. area
- For all devices: eff. $\geq 93\%$ ($\geq 94\%$ for 2 ke threshold)
- Highest eff. for focussed-beam irradiation with CNM-57: 98% in irr. area
- Possibly improvable by tilting sensor (15° under study)

Non-Uniform Irradiation	Unirr. Reference	PS Focussed	KIT Hole (circ.)	KIT Hole (slit)	
Φ [$10^{15} n_{eq}/cm^2$]	Unirr.	4.0 (max)	1.8	3.3	3.6
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Edge	Regular	Regular	Regular	Slimmed	Slimmed
Threshold [ke]	3	1.7	2	3	3

Conclusions

- Slim-edge and non-uniformly irradiated 3D AFP sensors studied
- Good performance despite low sensor quality
- Slim edge:
 - **IV, noise and efficiency in test beam unaffected** by edge-cutting with diamond saw (FBK: efficient edge)
 - **Inactive pixel-sensor region highly reduced** (from >1 mm to 100-180 μm)
- Non-uniform irradiation:
 - **High efficiency of 94-98% achievable** in irradiated part (for $\text{thr} \leq 2 \text{ ke}$)
- Outlook:
 - CNM AFP production run with 12 wafers expected to end in April
 - Module production by IZM (UBM, flip-chip), IFAE (wirebonding) and Oslo (flex design)
 - Test beams at the end of the year with a first system of tracking and timing detectors
 - AFP planned to be installed end of 2015
 - **second use of 3D silicon sensors in HEP experiment!**

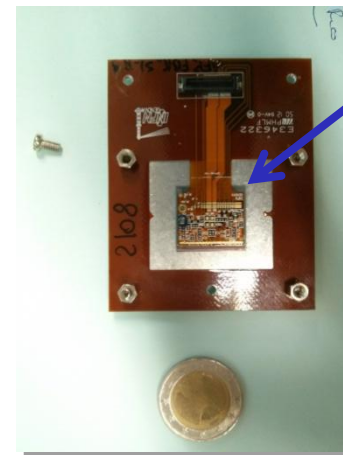
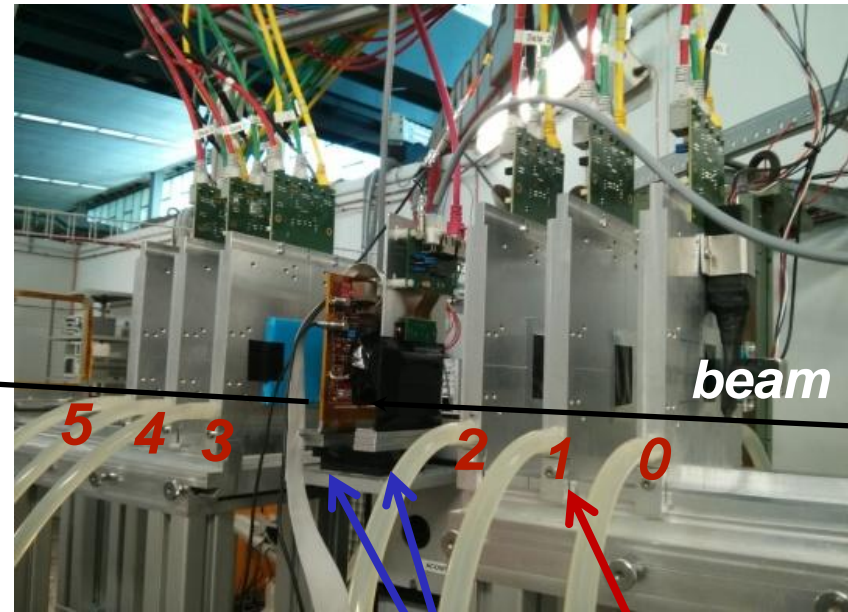
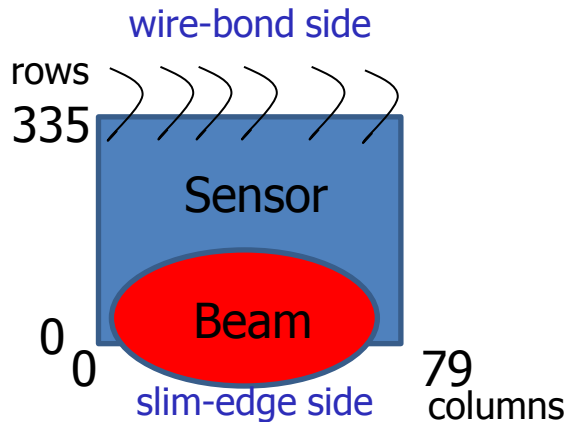


BACKUP

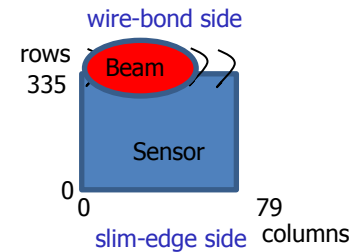
DESY Test Beam

- Check performance in test beam
 - DESY II 4 or 5 GeV electrons
 - ACONITE telescope (EUDET type)
 - 6 planes of MIMOSA-26:
 - 660k Si pixels (18.4 μm pitch)
 - Trigger: 4 scintillators
 - Special study of **edge efficiency** of first rows (slim-edge side)

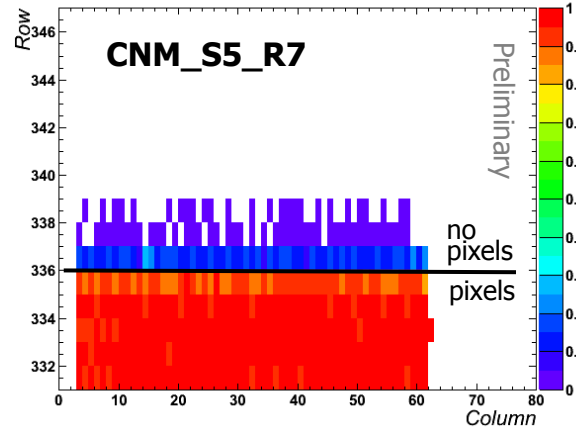
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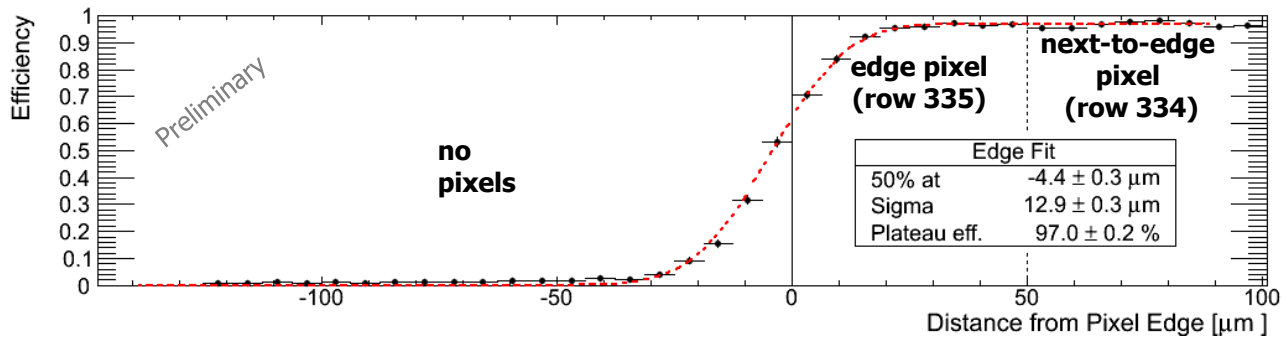
Regular Unslimmed Edge (Top Side)



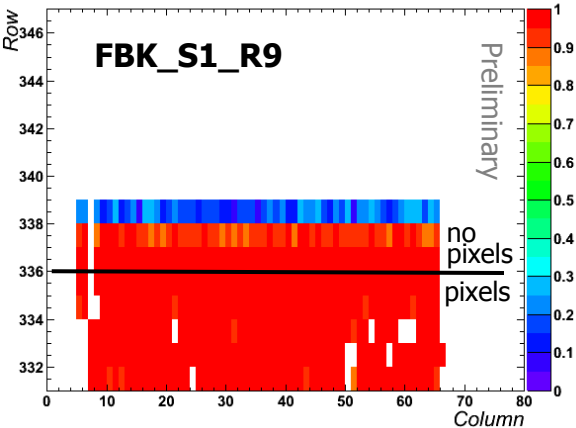
Y Edge Efficiency Sensor Map Top



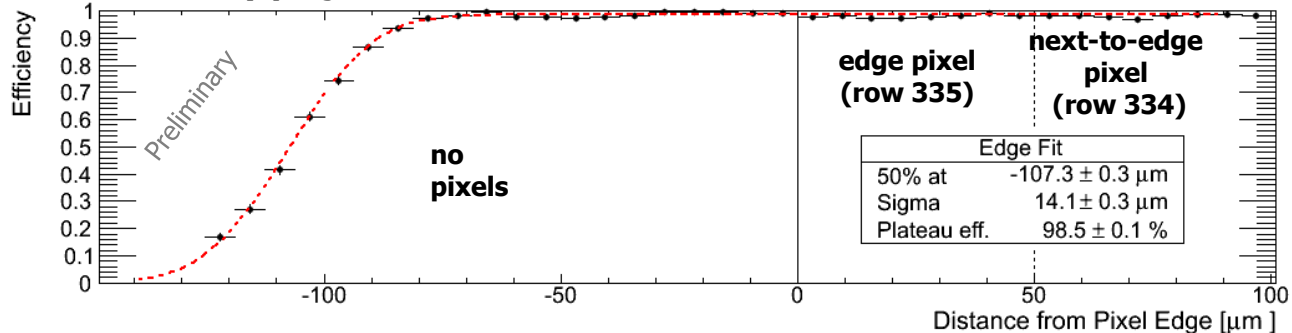
Efficiency projection



Y Edge Efficiency Sensor Map Top



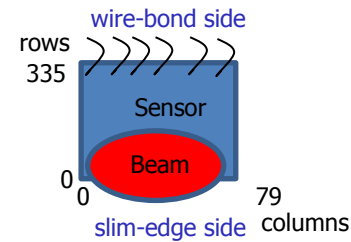
Efficiency projection



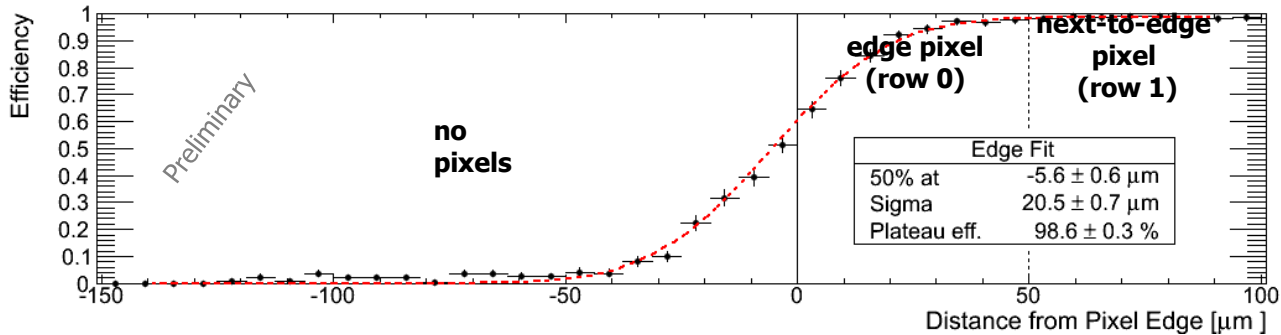
- Efficiency stable up to last pixel
 - Smearing due to beam telescope resolution
 - For FBK even $\sim 100 \mu\text{m}$ beyond (active edge due to absence of guard ring); a bit noisy/hot pixels \rightarrow masked

Slim Edge (Bottom Side)

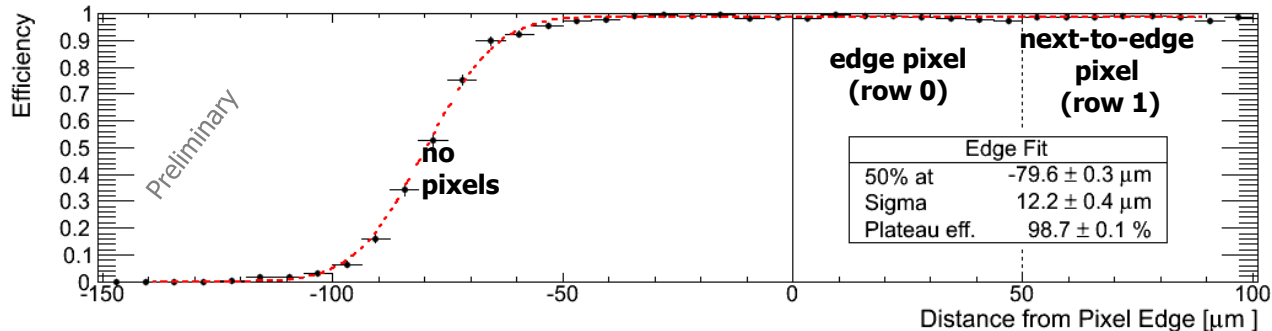
Other devices



Efficiency projection CNM_S3_R5

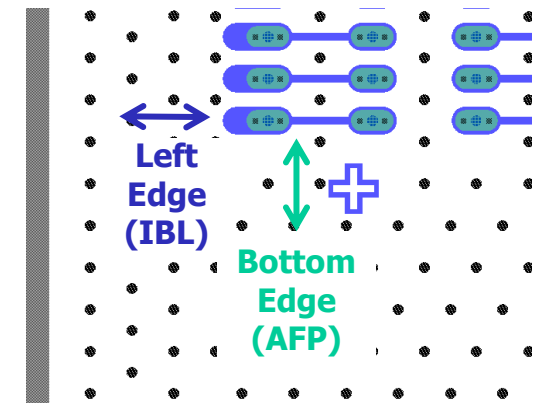
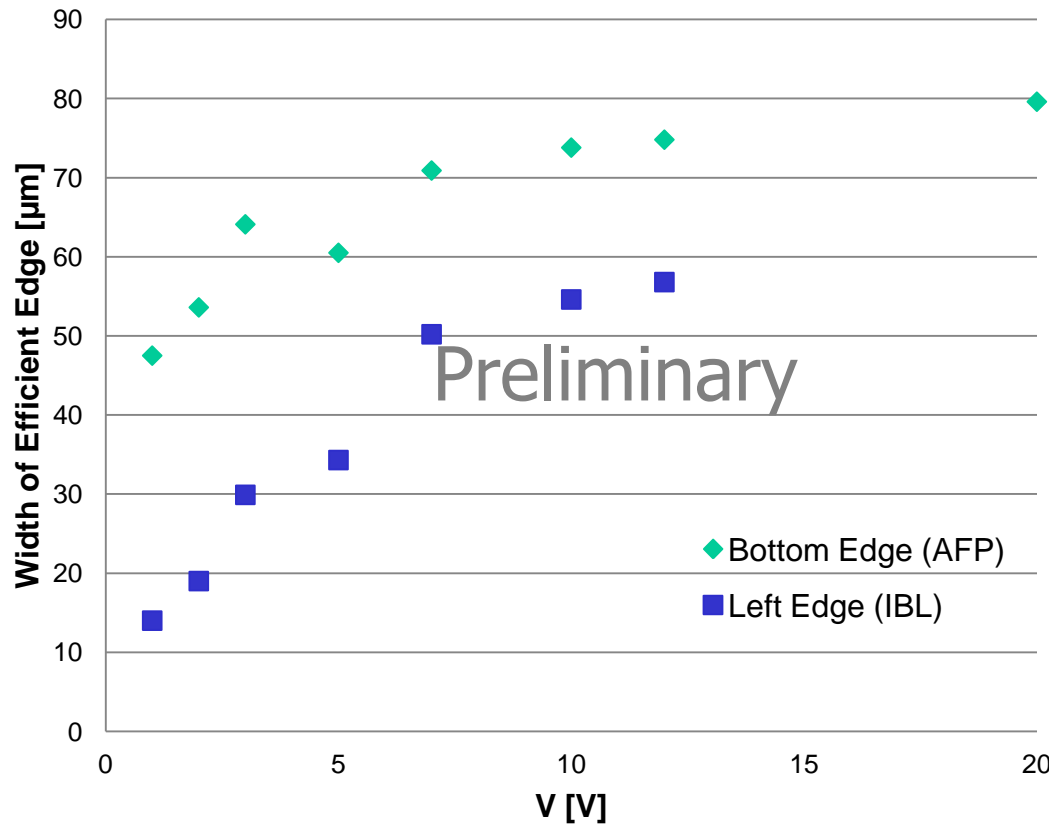
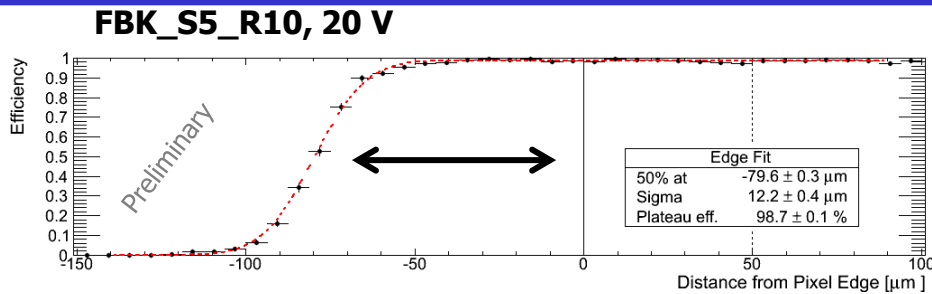


Efficiency projection FBK_S5_R10



- Efficiency stable up to last pixel
 - For FBK even $\sim 85 \mu\text{m}$ beyond (active edge due to absence of guard ring); a bit noisy/hot pixels \rightarrow masked
- \rightarrow same behaviour as for non-slimmed edge!

Development of Efficient Edge in FBK Sensor with Voltage



- Width of efficient edge increases with voltage (depletion zone increases)
- Saturation between first and second guard line beyond last pixel
- **Bottom edge** has larger width of efficient edge than **left edge**

Electrical Characteristics

- Not optimal sensors from beginning (IBL spares)
 - Merged/disconnected bump bonds, partly low V_{BD}

FBK_12_02_08

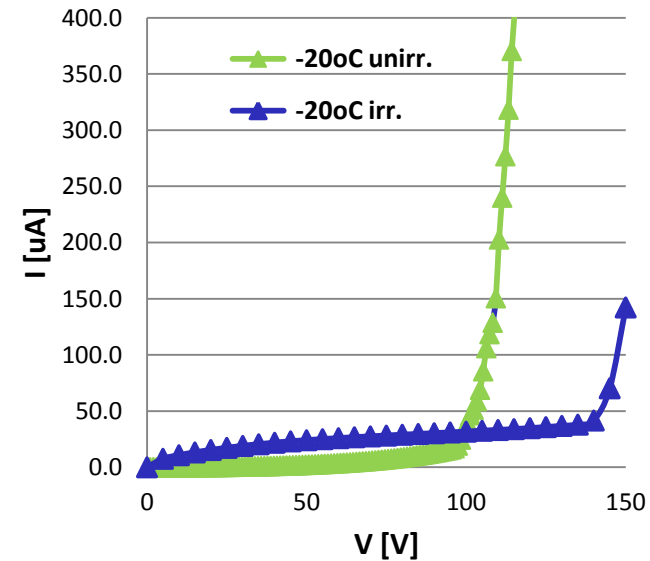
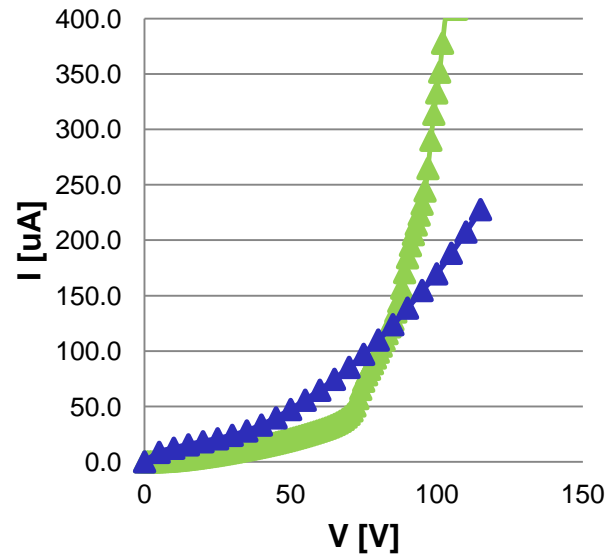
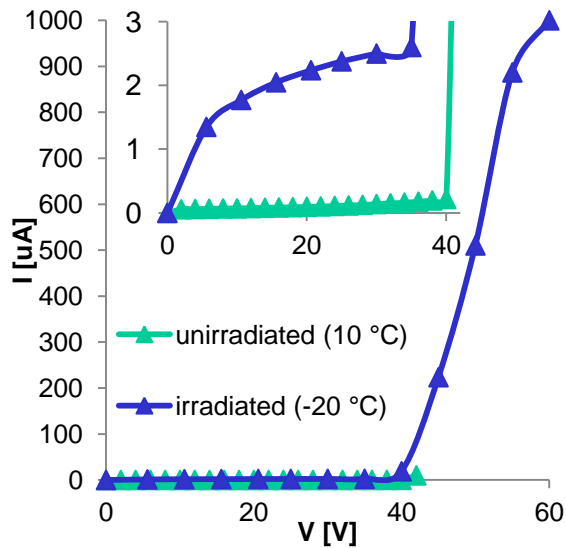
CNM_S5_R7

CNM_S3_R5

- $V_{BD} \sim 40$ V before and after irradi.
- Able to bias up to 58 V

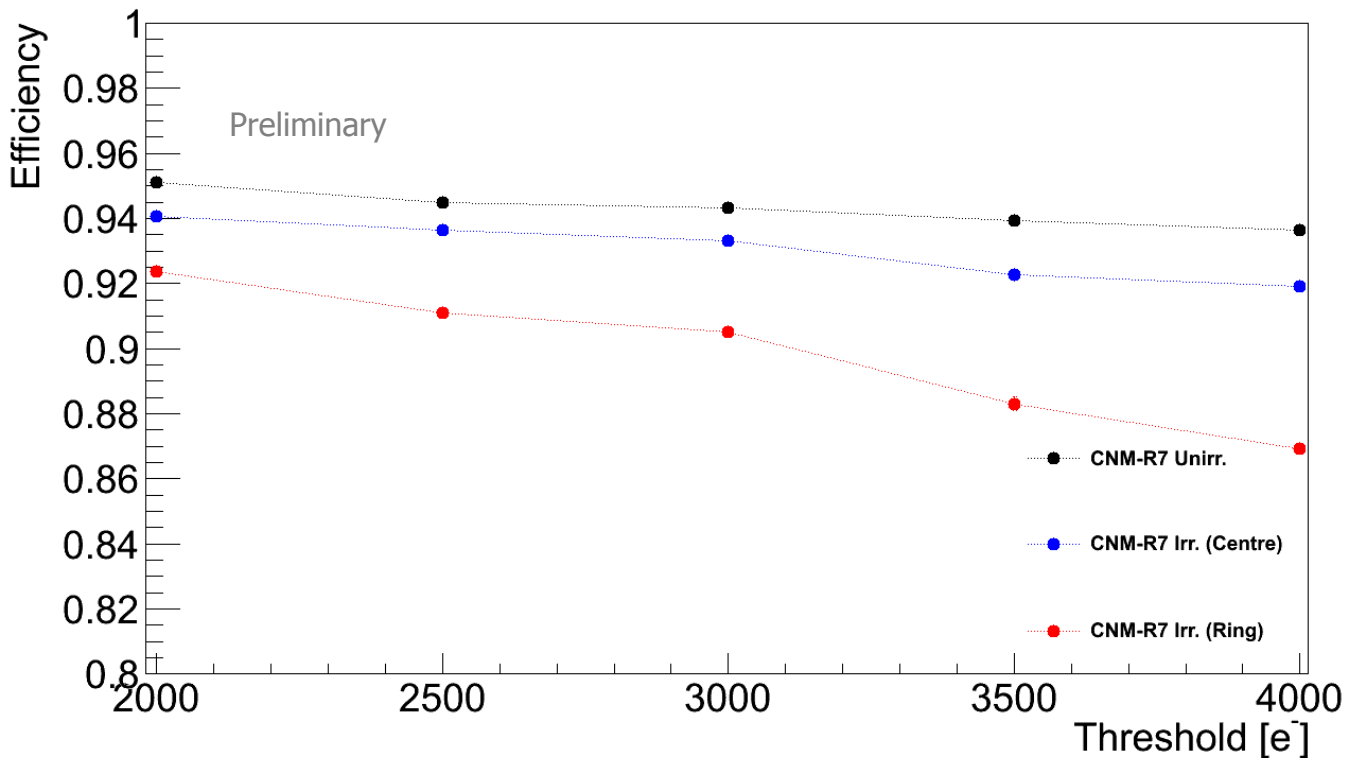
- Soft BD
- Lower I after irr. at high V

- Shift of V_{BD} to higher V
- Lower I after irr. at high V



Efficiency vs. Threshold

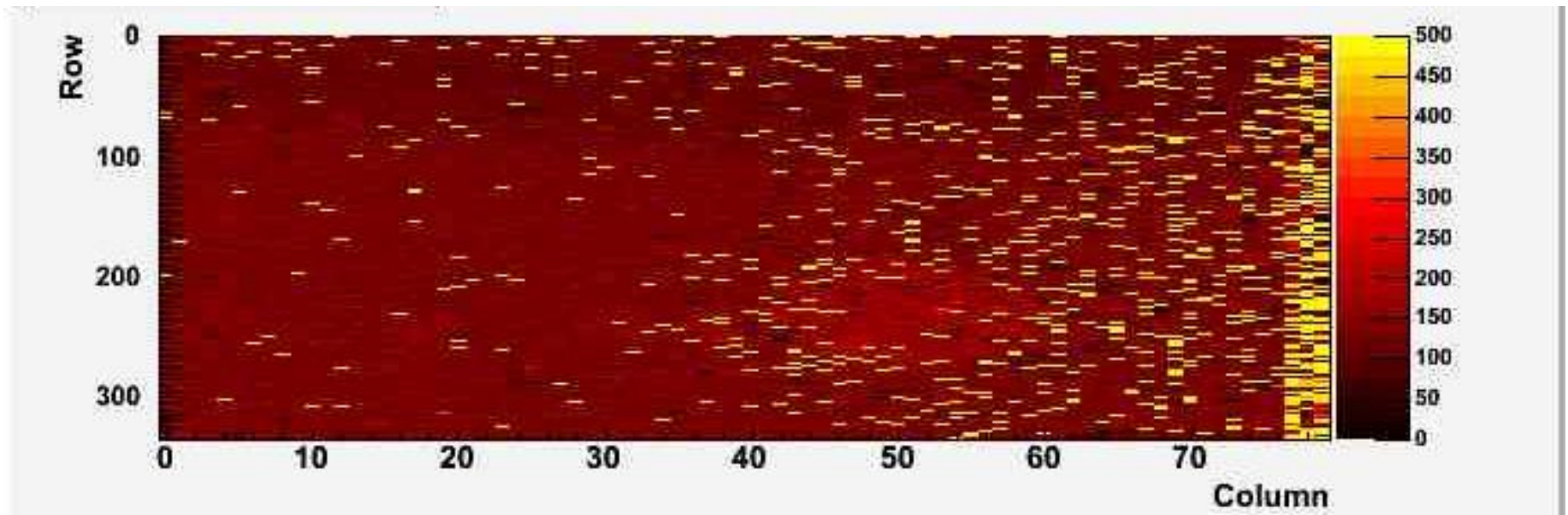
- Improvement of 1% per 1000e reduction of threshold for unirr. and irr. (centre) area
- Even more for higher irradiated ring



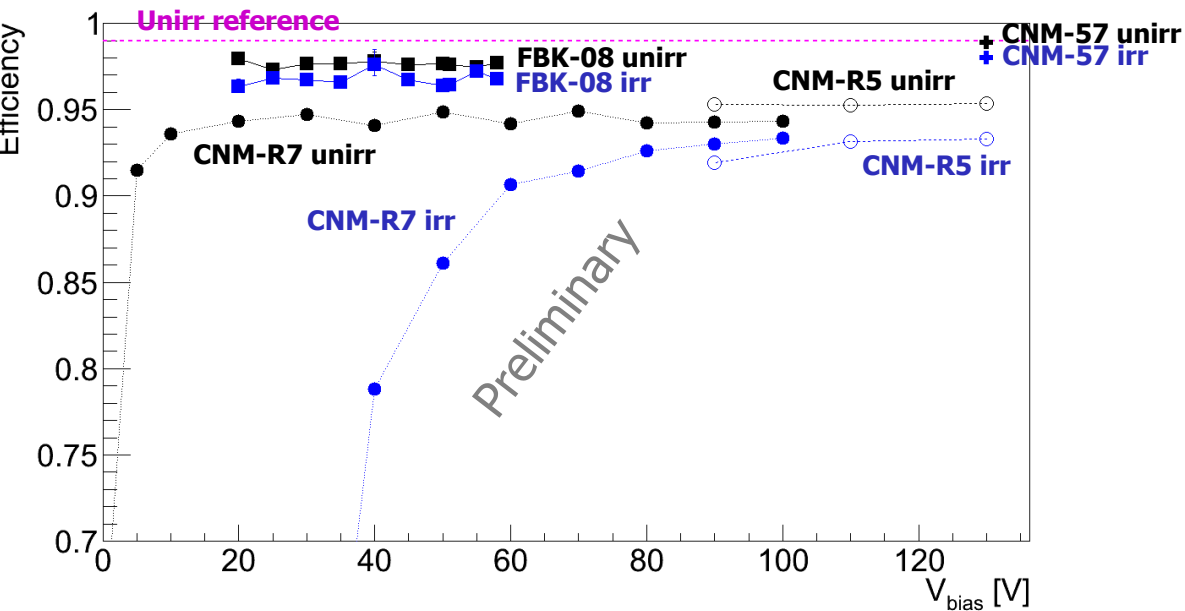
Noise of irradiated sensor

- Noise outside irradiated region ~ 130 e
- Noise inside irradiated region slightly higher (by about 10-20e)

FBK-12-02-08, 50 V



Efficiency



- Irradiated area (centre) almost as efficient as unirr. area
- Irradiation through hole (KIT): offset for CNM devices
 - Both unirr. and irr. area
 - Note different fluence, irr. area, threshold, edge
 - Threshold of 2 ke gives 1% more
 - Problem with tuning? Non-uniform eff. even in unirr. Area
- For all devices: eff. \geq 93%
- Highest eff. for focussed-beam irradiation with CNM-57: 98% in irr. area
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Sample	CNM 55	CNM 57	FBK 12_02_08	CNM S5-R7	CNM S3-R5
Edge	Regular	Regular	Regular	Slimmed	Slimmed
Threshold [ke]	3	1.7	2	3 (2)	3
Eff _{max} (unirr) [%]	99	99	98	94 (95)	94
Eff _{max} (irr) [%]	-	98	97	93 (94)	93